



Docket No.: V9661.0056

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Jun Wang et al.

Application No.: 10/787,169

Confirmation No.: 4887

Filed: February 27, 2004

Art Unit: 1756

For: MULTIPLE EXPOSURE METHOD FOR

Examiner: K. Duda

CIRCUIT PERFORMANCE IMPROVEMENT

STATUS INQUIRY

U.S. Patent and Trademark Office 220 20th Street S. Customer Window Crystal Plaza Two, Lobby, Room 1B03 Arlington, VA 22202

Dear Sir:

It is respectfully requested that the attorney named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive an Office Action from the Patent and Trademark Office.

Dated: September 13, 2006

Respectfully submitted,

lan R. Blum

Registration No.: 42,336
DICKSTEIN SHAPIRO LLP
1177 Avenue of the Americas
New York, New York 10036-2714

(212) 277-6500

Attorney for Applicant

IRB/mgs